

PATENT APPLICATION

Docket No.: 53433/2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: )  
Younan Xia )  
Serial No.: 10/732,910 ) Art Unit  
Filed: December 9, 2003 ) 1775  
For: METHODS OF NANOSTRUCTURE FORMATION )  
AND SHAPE SELECTION )  
Examiner: John J. Zimmerman )

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is filed in response to the Office Action mailed March 23, 2007 in which the Examiner advised that claims 1-46 are subject to restriction under 35 U.S.C. § 121. A petition and fee for a two-month extension of time are filed simultaneously herewith.

Referring to the classification terminology employed by the Examiner, Applicants hereby elect Group II (claims 4-14) for prosecution without traverse.